



IFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: OGIHARA, M.                      Group Art Unit: 2812  
Serial No. 10/716,601                      Examiner: MULPURI, SAVITRI  
Filed: 11/20/03  
Title: SEMICONDUCTOR DEVICE AND METHOD OF MANUFACTURING THE  
SAME

SUBSTANCE OF INTERVIEW

Commissioner for Patents                      Submitted: 06/24/04  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

With respect to the telephone interview of  
04/16/04, applicant hereby submits the substance of the  
interview as follows:

Participant:

Examiner: Exa Mulpuri

Agent of Applicant: Satoru TAKEUCHI

Date and type of interview: April 16, 2004, telephonic  
interview

Exhibit shown or demonstration conducted: None

Claims Discussed: claims 20-23

Prior Art Discussed: N/A

Principal points of what was discussed and agreed:  
discussed and agreed that non-elected claims 20-23 will be  
canceled.

Application Number: 10/713,200

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Art Unit: 2833

Respectfully submitted,

  
Satoru Takeuchi

Reg. No. 53,670

Agent for Applicant

Date: 06/24/04

TAKEUCHI & TAKEUCHI

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